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Bib Data Sheet

CONFIRMATION NO. 1365

SERIAL NUMBER 10/774,623	FILING DATE 02/10/2004 RULE	CLASS 451	GROUP ART UNIT 3723	ATTORNEY DOCKET NO. 053848-5018
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APPLICANTS

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** CONTINUING DATA ***** *yes S.A.*
 This application is a CON of PCT/JP02/08349 08/19/2002

** FOREIGN APPLICATIONS ***** *yes S.A.*
 JAPAN 2001-251421 08/22/2001

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
 ** 09/02/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY JAPAN	SHEETS DRAWING 14	TOTAL CLAIMS 43	INDEPENDENT CLAIMS 7
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Verified and Acknowledged
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TITLE
 Method and device for simulation, method and device for polishing, method and device for preparing control parameters or control program, polishing system, recording medium, and method of manufacturing semiconductor device

FILING FEE	FEES: Authority has been given in Paper	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of
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